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INFORMATION DISCLOSURE STATEMENT BY APPLICANT		O I P E FEB 17 2000 PATENT & TRADEMARK OFFICE	
		Applicant: Shieh et al.	
		Filing Date: November 12, 1999	Group: 1743

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date
(MP)	5,147,607	September 15, 1992	Mochida	—	—	
(MM)	5,843,767	December 1, 1998	Beattie	—	—	

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation Yes No
(MP)	EP 0527905B1	August 5, 1991	—	—	—	
(MM)	WO 98/43739	March 24, 1998	—	—	—	

OTHER DOCUMENTS - Including Author, Title, Date, Pertinent Pages, Etc.

(MP)	Becker, H., Dietz, W. & Dannberg, P. 1998. "Microfluidic manifolds by polymer hot embossing for μ-TAS applications." <i>Micro-TAS' 98, Banff</i> , pp. 253-256.
	Effenhauser, C.S., Bruin, G.J.M., Paulus, A. & Ehrat, M. 1997. "Integrated capillary electrophoresis on flexible silicone microdevices: analysis of DNA restriction fragments and detection of single DNA molecules on microchips." <i>Anal. Chem.</i> , vol. 69, pp. 3451-3457.
	Lee, L.P., Berger, S.A., Pruitt, L. & Liepmann, D. 1998. "Key elements of a transparent teflon® microfluidic system." <i>Micro-TAS' 98, Banff</i> , pp. 245-248.
	McCormick, R.M., Nelson, R.J., Alonso-Amigo, M.G., Benvegnù, D.J. & Hopper, H.H. 1997. "Microchannel electrophoretic separations of DNA in injection-molded plastic substrates." <i>Anal. Chem.</i> , vol. 69, pp. 2626-2630.
↓	Webster, J.R., Burns, M.A., Burke, D.T. & Mastrangelo, C.H. 1998. "An inexpensive plastic technology for microfabricated capillary electrophoresis chips." <i>Micro-TAS' 98, Banff</i> , pp. 249-252.

Examiner	Date Considered
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with any communication.

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